

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/687,643	MINO, TETSUYA	
Examiner		Art Unit		Page 1 of 1
Paul D. Kim		3729		

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	B	US-5,802,700	09-1998	Chen et al.	29/603.14
	C	US-5,438,747	08-1995	Krounbi et al.	29/603.16
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.